L Number	Hits	Search Text	DB	Time stamp
_	293	430/20.ccls.	USPAT	2004/01/28 17:41
_	472	438/30.ccls.	USPAT	2004/01/28 16:43
_	563	438/149.ccls.	USPAT	2004/01/28 17:16
_	127	· ·	USPAT	2004/01/28 17:23
		photoresist		
_	12		USPAT	2004/01/28 17:24
		electrode" and "second capacitor		· ·
		electrode"		,
_	44	438/30,149.ccls. and samsung.as.	USPAT	2004/01/28 17:26
_	5	438/30,149.ccls. and pattern\$ with "active	USPAT	2004/01/28 17:30
		layer" with "passivation layer"		
_	59		USPAT	2004/01/28 17:30
_	34	438/30,149.ccls. and "masking step"	USPAT	2004/01/28 17:31
-	12	438/30,149.ccls. and "first metal layer"	USPAT	2004/01/28 17:31
		and "second metal layer" and "active"		
		layer"		
_	50	438/30,149.ccls. and "first metal layer"	USPAT	2004/01/28 17:35
		and "second metal layer"		
_	951	257/59.ccls.	USPAT	2004/01/28 17:35
_	855	257/72.ccls.	USPAT	2004/01/28 17:35
-	8	257/59,72.ccls. and pattern\$ with	USPAT	2004/01/28 17:36
		passivation with "active layer"		
-	. 65	257/59,72.ccls. and "first metal layer"	USPAT	2004/01/28 17:37
		and "second metal layer"		
-	15	257/59,72.ccls. and "first capacitor	USPAT	2004/01/28 17:37
		electrode" and "second capacitor		
		electrode"		
_	177		USPAT	2004/01/28 17:37
		photoresist		
-	60		USPAT	2004/01/28 17:37
-	79	257/59,72.ccls. and lg.as.	USPAT	2004/01/28 17:38
-	27	257/59,72.ccls. and "masking step"	USPAT	2004/01/28 17:39
-	48		USPAT	2004/01/28 17:40
-	108	349/38,39,42,43,44.ccls. and passivation	USPAT	2004/01/28 17:40
		and photoresist		
-	22	349/38,39,42,43,44.ccls. and "first	USPAT	2004/01/28 17:40
ŀ		capacitor electrode" and "second capacitor		
		electrode"		
-	96	,,,,, <u>-</u> <u>-</u>	USPAT	2004/01/28 17:42
		and "active layer"		
-	444		USPAT	2004/01/28 17:42
-	68	349/38,39,42,43,44.ccls. and samsung.as.	USPAT	2004/01/28 17:42
	108	349/38,39,42,43,44.ccls. and lg.as.	USPAT	2004/01/28 17:42